

Search Notes				Application/Control No.	Applicant(s)/Patent under Reexamination	
				10/629,440	LAWS ET AL.	
				Examiner	Art Unit	
				José V. Chen	3637	
SEARCHED				SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
Class	Subclass	Date	Examiner	DATE	EXMR	
108	131	1/9/06	SLC	1/4/06	SLC	
	132					
	133					
	129					
	117					
	125					
248	439					
	188.6					
	439					
	188.1					
	188					
	436					
	292.12					
403	93					
	92					
	92					
	94					
	103	6/13/06	JLC			
SEARCHED				SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
Class	Subclass	Date	Examiner	DATE	EXMR	
108	131	6/13/06	SLC			
	132					
	132					
248	436					
INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner	DATE	EXMR	
108	131	6/13/06	SLC			
	132					
	132					
248	436					